

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Attorney Docket Number	42637/GDL/N288
Application Number	To be assigned
Filing Date	December 17, 2001
Applicant(s)	Jayant Neogi
Group Art Unit	To be determined
Examiner Name	To be determined

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	3,840,721	10/1974	Monk	219	121	
	3,908,183	09/1975	Ennis, Jr.	357	65	
	4,334,139	06/1982	Witteck et al.	219	121.3	
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	4,425,796	01/1984	Hakoune	63	32	
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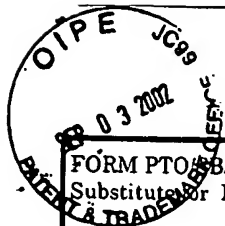
FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)	Attorney Docket Number	42637/GDL/N288
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	Applicant(s)	Jayant Neogi
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FOREIGN PATENT DOCUMENTS							
EXAMINER INITIALS	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	WO 99/34197	07/1999	WIPO				
	2033096A	05/1980	GB	G03B	41/00		

OTHER DOCUMENTS			
EXAMINER INITIALS	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	BRAUNSTEIN, et al., Depth profile of antimony implanted into diamond, Journal of Applied Physics, Vol. 50, No. 9, September 1979, Pgs. 5731 - 5735.		
	ENDENFELD et al., Force probe characterization using silicon three-dimensional structures formed by focused ion beam lithography, Journal of Vacuum Science and Technology B, Vol. 12, No. 6, 1994, Pgs. 3571-3575.		
	KOMURO, Ion Beam Exposure Apparatus Using Liquid Metal Source, 1982, Pgs. 155-159, Elsevier Squoia; Netherlands		
	International Search Report for PCT/US00/16761 Dated October 2, 2000		
EXAMINER SIGNATURE		DATE CONSIDERED	02/03/04
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FORM PTO/B/08A/B (10-01)
Substitute for PTO-1449A/B

INFORMATION DISCLOSURE

STATEMENT BY APPLICANT

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Attorney Docket Number 42637/GDL/N288

Application Number 10/018,817

Filing Date December 17, 2001

Applicant(s) Jayant Neogi

Group Art Unit To be determined

Examiner Name To be determined

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	DOCUMENT NUMBER Number · kind code ² . (If known)	PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	Foreign Patent Document Country Code ³ · Number ⁴ · Kind Code ⁵ (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T ⁶ (✓)

OTHER DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		R. KALISH, Ion implantation in diamond: general remarks, June 1993, 6.1, pp. 191-92
		R. KALISH, Volume expansion of diamond during ion implantation, June 1993, 6.3, pp. 194-195
		R. KALISH, Implantation-induced damage and its annealing in diamond, June 1993, 6.4, pp. 196-201
		R. KALISH, p- and n- type doping of diamond by ion implantation, June 1993, 6.6, pp. 205-208
		R. KALISH, Applications of ion implantation of diamond, June 1993, 6.9, pp. 213-214
		W.J.P. VAN ENCKEVORT, Etching of diamond, October 1993, 10.3, pp. 301-308

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